

Application Serial No. 10/738,397
Reply to Office Action of June 26, 2006

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PATENT
Docket: CU-3496

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application:	Seung Woo JIN et al.]	GRP ART UNIT: 1765
]	
Serial No:	10/738,397]	Ex.: Tran, Binh X
]	
Filed:	December 17, 2003]	
For:	Method for Fabricating Semiconductor Device		

Certification under 37 C.F.R. §1.8(a)

The USPTO Central Fax No. (571) 273-8300

Date of Fax Transmittal: July 20, 2006

I hereby certify that this paper (along with any paper referred to as being attached or enclosed) is being transmitted to the United States Patent and Trademark Office to the fax number and on the date indicated above.


Maggie Pomroy

The Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

RESPONSE TO RESTRICTION REQUIREMENT

In the Office Action dated June 26, 2006, setting a 1-month shortened statutory period for a reply ending on July 26, 2006, the pending Claims 1-15 were restricted as follows:

Species A (claims 1-6 and 8-14): wherein the ion implantation process is performed with the tilt angle is 0 to 30° and the number of rotations is 2 to 4;

Species B (claims 1-5, 7-13 and 15): wherein the ion implantation process is performed in one time without the tilt angle.

Applicant hereby elects provisionally **Species A, Claims 1-6 and 8-14** with traverse.

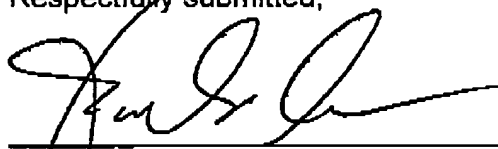
The grounds for traversal are that, if the generic linking claims 1 and/or 2 are

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finally held allowable, those withdrawn claims that depend from the generic linking claims 1 and/or 2 should be reinstated and allowed in the same application. In any event, the Applicant retains the right to present the non-elected in a divisional application.

Respectfully submitted,



Dated: July 20, 2006

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